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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Robert Bristol et al. § Art Unit: 1756  
Serial No.: 10/679,816 § Examiner: Kathleen Duda  
Filed: October 6, 2003 § Atty Docket: ITL.1023US  
For: Enhancing Photoresist § P16710  
Performance Using  
Electric Fields § Assignee: Intel Corporation

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

In response to the restriction requirement mailed February 8, 2006, please amend the above-referenced patent application as follows:

Date of Deposit: February 24, 2006  
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Cynthia L. Hayden*  
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